



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUJITA, Kenichi**

Group Art Unit: 1773

Serial No.: 10/660,745

Examiner: **Monique R. JACKSON**

Filed: **September 12, 2003**

P.T.O. Confirmation No.: 5996

For. **HEAT RADIATION SHIELDING COMPONENT DISPERSION, PROCESS FOR ITS PREPARATION AND HEAT RADIATION SHIELDING FILM FORMING COATING LIQUID, HEAT RADIATION SHIELDING FILM AND HEAT RADIATION RESIN FORM WHICH ARE OBTAINED USING THE DISPERSION**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

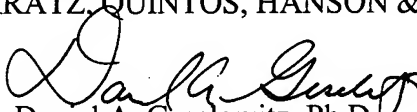
Date: March 3, 2006

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated October 7, 2005 for two months, from January 7, 2006, to March 7, 2006.

Attached please find a check in the amount of \$580.00: \$450.00 to cover the cost of the extension and \$130.00 to cover the cost of the Terminal Disclaimer filing fee for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,
ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP


Daniel A. Geselowitz, Ph.D.

Agent for Applicant
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01 FC:1252

450.00 DP

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PATENT TRADEMARK OFFICE